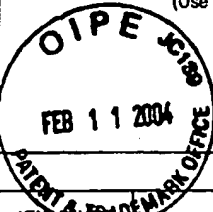
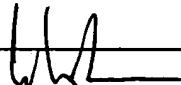
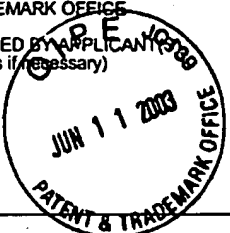
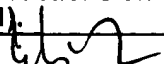


FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		ATTY DOCKET NO.  <b>01263.002067.</b>		APPLICATION NO.  <b>09/981,844</b>			
		APPLICANT  <b>ADAM MICHAEL BAUMBERG</b>					
		FILING DATE  <b>October 19, 2001</b>		GROUP  <b>2621</b>			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<i>W</i>	2002/0085748 A1	07/04/92	Baumberg	382	154		
<i>Cml</i>	2003/0001837 A1	01/02/03	Baumberg	345	449		
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
<i>Cml</i>	JP	11-328441 A	11/30/99	Japan	G06T	15/70	Abstract
<i>Cml</i>	JP	2000-268189 A	09/29/00	Japan	G06F	15/00	Abstract
<i>Cml</i>	WO	98/18117	04/30/98	PCT	G09G	A2	Eng. Orig.
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Cml</i>		J. D. Foley et al., "Computer Graphics Principles and Practice", Addison-Wesley Pub. Co., Second Ed., Section 16.3.2, pp. 741-744 (1997).					
<i>Cml</i>		P. J. Sloan et al., "Importance Driven Texture Coordinate Optimization", Eurographics '98, Vol. 17, No. 3 (1998).					
EXAMINER				DATE CONSIDERED		<b>10-17-05</b>	

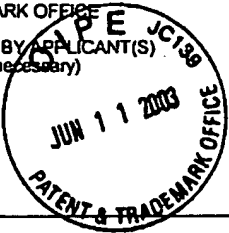
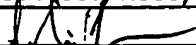
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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
Cm		Wolfgang Niem et al., "Automatic Reconstruction of 3D Objects Using a Mobile Monoscopic Camera." Image and Vision Computing 17, pp. 125-134. (1999).					
Cm		Peter J. Burt et al., "A Multiresolution Spline with Application to Image Mosaics." ACM Transactions on Graphics (TOG), Vol. 2, No. 4, pp. 217-236 (October 1983).					
Cm		Paul E. Debevec et al., "Modeling and Rendering Architecture from Photographs: A Hybrid Geometry and Image-Based Approach." In Conference Proceedings ACM SIGGRAPH, pp. 11-20 (1996).					
Cm		Frédéric Pighin et al., "Synthesizing Realistic Facial Expressions from Photographs." Proceedings of the 25 <sup>th</sup> Annual Conference on Computer Graphics, pp. 1-9 (July 1998).					
Cm		Fausto Bernardini et al., "High-Quality Texture Reconstruction from Multiple Scans." IEEE Transactions on Visualization and Computer Graphics, Vol. 7, No. 4, pp. 318-332 (Oct.-Dec. 2001).					
EXAMINER				DATE CONSIDERED			
				<b>Oct 10-17-05</b>			

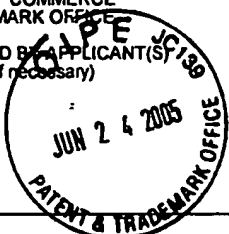
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Cml		Eyal Ofek et al., "Multiresolution Textures from Image Sequences." IEEE Computer Graphics and Applications, Vol. 17, No. 2, pp. 18-29 (March 1997).					
Cml		Igor Guskov et al., "Multiresolution Signal Processing for Meshes." In Conference Proceedings ACM SIGGRAPH, pp. 325-334 (1999).					
Cml		Matthias Eck et al., "Multiresolution Analysis of Arbitrary Meshes." In Conference Proceedings ACM SIGGRAPH, pp. 173-182 (1995).					
Cml		Pedro V. Sander et al., "Texture Mapping Progressive Meshes." In Conference Proceedings ACM SIGGRAPH, pp. 409-423 (August 2001).					
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Cml		Maneesh Agrawala et al., "Efficient Image-Based Methods for Rendering Soft Shadows." Proceeding of SIGGRAPH 2000, Computer Graphics Proceedings, Annual Conference Series, pp. 375-384 (July 2000).					
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				10-17-05			

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			FILING DATE  <b>October 19, 2001</b>		GROUP  <b>2621</b>				
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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)					<div style="border: 1px solid black; padding: 10px; width: fit-content; margin: auto;"> <b>RECEIVED</b>  <b>JUN 12 2003</b>            Technology Center 2600         </div>				
Cml		Yizhou Yu., "Efficient Visibility Processing for Projective Texture Mapping." Computer & Graphics, Vol. 23, pp. 245-253 (1999).							
Cml		Reinhard Koch et al., "Multi Viewpoint Stereo from Uncalibrated Video Sequences." ECCV '98, vol. I, pp. 55-71 (June 1998).							
Cml		C. Rocchini et al., "Multiple Textures Stitching and Blending on 3D Objects." Eurographics Rendering Workshop, (June 1999).							
Cml		Hendrik P. A. Lensch, "A Silhouette-Based Algorithm for Texture Registration and Stitching." Graphical Models, Vol. 63, No. 4, pp. 245-262 (2001).							
Cml		Wojciech Matusik et al., "Image-Based Visual Hulls." Proceedings of SIGGRAPH 2000, pp. 369-374 (2000).							
Cml		Dan Piponi et al., "Seamless Texture Mapping of Subdivision Surfaces by Model Pelting and Texture Blending." Proceeding of SIGGRAPH 2000, pp. 471-478 (July 2000).					EXAMINER <i>[Signature]</i>		
DATE CONSIDERED <b>10-17-05</b>									

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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		APPLICANT <b>ADAM MICHAEL BAUMBERG</b>					
		FILING DATE <b>October 19, 2001</b>		GROUP <b>2623</b>			
U.S. PATENT DOCUMENTS							
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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
<i>Cml</i>	JPA	7-254072 A	10/03/95	Japan			Abstract
<i>Cml</i>	JPA	6-348860 A	12/22/94	Japan			Abstract
<i>Cml</i>	JPA	2001-126084 A	05/11/01	Japan			Abstract
<i>Cml</i>	JPA	11-120372 A	04/30/99	Japan			Abstract
<i>Cml</i>	JPA	8-147494 A	06/07/96	Japan			Abstract
<i>Cml</i>	JPA	2000-348196	12/15/00	Japan			Abstract
<i>Cml</i>	JPA	7-230555	08/29/95	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER <i>ML-2</i>				DATE CONSIDERED <i>10-17-05</i>			

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Sheet 1 of 1